



Docket No.: 034299-654

*Receipt*  
*Jaw*

APPLICANT: Simon Deleonibus, et al.

SERIAL NO.: 10/539,532

FILING DATE: June 17, 2005

TITLE: METHOD FOR FORMING PATTERNS ALIGNED ON EITHER SIDE  
OF A THIN FILM

EXAMINER: Unassigned

ART UNIT: 1763

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**CERTIFICATE OF MAILING**

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria VA 22313-1450, on the date printed below:

Date: 1-23-07

Name: Sharon E. Byam  
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST TO CORRECT FILING RECEIPT**

It is respectfully submitted that the Filing Receipt for the above-identified patent application has an error.

The **Foreign Applications** section is blank, but should contain the following data:

**“FRANCE 02 15980 12/17/2002”**

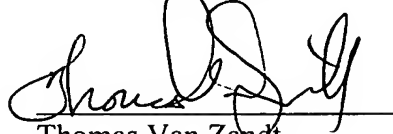
Please amend the Filing Receipt and appropriate records to reflect the correct priority information for the above-referenced patent application. A copy of the Filing Receipt is enclosed with the necessary correction indicated in red ink.

In addition, a copy of the Preliminary Amendment showing the correct priority information, as initially filed with the patent application on June 17, 2005, is enclosed as a reference.

No fee is believed to be due. However, the Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No. 50-1698.

Respectfully submitted,

THELEN REID & PRIEST LLP

A handwritten signature in black ink, appearing to read 'Thomas Van Zandt', is written over a horizontal line.

Thomas Van Zandt  
Reg. No. 43,219

Dated: 1/21/08

THELEN REID & PRIEST LLP  
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UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/539,532	06/17/2005	1763	900	034299-654	9	16	1

Robert E Krebs  
Thelen Reid & Priest  
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San Jose, CA 95164-0640

**RECEIVED**

SEP 25 2006

CONFIRMATION NO. 4554

CORRECTED FILING RECEIPT



\*OC000000020537479\*

THELEN REID & PRIEST  
IP DOCKETING

Date Mailed: 09/21/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

**Applicant(s)**

Maud Vinet, Grenoble, FRANCE;  
Simon Deleonibus, Claix, FRANCE;  
Bernard Previtali, Grenoble, FRANCE;  
Gilles Fanget, Reaumont, FRANCE;

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Adrienne Yeung-44000  
Yukiko Maekawa-50307

**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/FR03/50179 12/16/2003

Foreign Applications *FRANCE 02 15980 12/17/2002*  
If Required, Foreign Filing License Granted: 09/21/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/539,532**

Projected Publication Date: Not Applicable

Non-Publication Requested: No

Mail log \_\_\_\_\_ Date \_\_\_\_\_  
CPI \_\_\_\_\_ Date \_\_\_\_\_  
Excel \_\_\_\_\_ Date \_\_\_\_\_

Reviewed By: \_\_\_\_\_ Date: \_\_\_\_\_  
No Action required: \_\_\_\_\_  
Action Required: \_\_\_\_\_

**Early Publication Request:** No

**Title**

Method for forming patterns aligned on either side of a thin film

**Preliminary Class**

216

## **PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES**

Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process **simplifies** the filing of patent applications on the same invention in member countries, but **does not result** in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

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Applicants may wish to consult the USPTO booklet, "General Information Concerning Patents" (specifically, the section entitled "Treaties and Foreign Patents") for more information on timeframes and deadlines for filing foreign patent applications. The guide is available either by contacting the USPTO Contact Center at 800-786-9199, or it can be viewed on the USPTO website at <http://www.uspto.gov/web/offices/pac/doc/general/index.html>.

For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, <http://www.stopfakes.gov>. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**APPLICANT:** Maud VINET, et al.  
**SERIAL NO.:** unassigned  
**FILING DATE:** herewith  
**TITLE:** Method for Forming Patterns Aligned on Either Side of a Thin Film  
**EXAMINER:** UNASSIGNED  
**ART UNIT:** UNASSIGNED

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**COMMISSIONER FOR PATENTS**  
**P.O. Box 1450**  
**Alexandria VA 22313-1450**

**PRELIMINARY AMENDMENT**

Dear Sir:

Prior to examination, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks / Arguments** begin on page 3 of this paper.

**Amendments to the Specification:**

Please amend the specification by inserting the paragraph below, after the title on page 1.

**Cross-Reference to Related Application**

This application claims priority based on International Patent Application No. PCT/FR2003/050179, entitled "Method for Forming Patterns Aligned on Either Side of a Thin Film" by Maud Vinet, Simon Deleonibus, Bernard Previtali and Gilles Fanget, which claims priority of French Application No. 02/15980 filed on December 17, 2002, and which was not published in English.

**REMARKS**

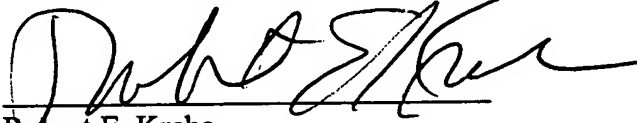
Entry of the foregoing amendment to the specification is requested to comply with the requirements of 37 C.F.R. 1.78(a)(2).

Favorable consideration and an early allowance of this application are earnestly solicited.

If the Examiner should be of the opinion that a telephone conference would be helpful in resolving any outstanding issues, the Examiner is urged to contact the undersigned.

Respectfully submitted,  
THELEN REID & PRIEST LLP

Dated: Jan 16, 2005

  
Robert E. Krebs  
Reg. No. 25,885

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